



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **HAYASHI, Nobuhiko**

Group Art Unit: **2828**

Serial No.: **09/532,786**

Examiner: **Armando RODRIGUEZ**

Filed: **March 22, 2000**

P.T.O. Confirmation No.: **8588**

FOR: SEMICONDUCTOR LASER DEVICE AND METHOD OF FABRICATING THE SAME

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 13, 2004

Sir:

In response to the Office Action dated **September 2, 2004**, extended to **January 2, 2005** by a **one (1)** month Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 9 of this paper.